Thermally Managed Z-scan Measurements of Amorphous TiO₂ Films

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Outline

Introduction: amorphous TiO₂ films

Standard z-scan

Thermally managed z-scan

Conclusions and Discussion

Titanium Dioxide

Wide Bandgap: 3.2 eV (387 nm)

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Wide Bandgap: 3.2 eV (387 nm) High index: 2.5 Excellent for 800 nm: Nonresonant (ultrafast) nonlinearity Low two-photon absorption

What is the nonlinearity for TiO₂ near 800 nm?

Z-Scan of Bulk Rutile







Z-Scan of Bulk Rutile



How should we optimize our thin films?

Optimization of thin films

Crystalline Phases: Amorphous Anatase Rutile



Optimization of thin films

Refractive Index



Optimization of thin films

Refractive IndexAmorphous: 2.35Anatase:2.45



Optimization of thin films

Refractive IndexAmorphous: 2.35Anatase:2.45

Guiding Losses Amorphous: 1 dB/cm Anatase: 5 dB/cm



Low loss amorphous TiO₂

Low loss amorphous TiO₂

Deposition Method: Reactive Sputtering Thickness: 2.2 micron Substrate: Fused Silica (500 micron) Guiding Losses: ~1 dB/cm

What is the nonlinearity of amorphous TiO₂?

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Are there thermal effects?



Boyd, R. W. Nonlinear optics. 2nd edn



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Laser Specifications

Type:Amplified Ti:Sapphire (CPA)Center λ:800 nmPulse Duration:100 fsRepetition Rate:10kHz - 250kHz



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w0 (measured): 37 micron zR (from fitting): 2.1 mm Approximate M²: 1.8 10 kHz **Repetition Rate: Pulse Duration:** 100 fs Max Power: 18 mW 0.08 J/cm² Max Fluence: S parameter: 0.016

What power should we use?

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Reported Damage Threshold: 0.55 J/cm²

Yao, J. et al. Thin Solid Films 516, 1237-1241 (2008).

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Reported Damage Threshold:0.55 J/cm²Our Maximum Fluence:0.08 J/cm²

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What power should we use?

Reported Damage Threshold:0.55 J/cm²Our Maximum Fluence:0.08 J/cm²Low Power Used:0.002 J/cm²

Yao, J. et al. Thin Solid Films 516, 1237-1241 (2008).









Sample has been changed



What about the closed aperture?

Closed Aperture (CA/OA)



Closed Aperture (CA/OA)



Closed Aperture (CA/OA)



Sample has been changed



What does the sample look like after?

Optical microscopy



Optical microscopy (enhanced)



Optical microscopy (enhanced)







What is the time scale of the darkening?

Timed Exposure (Open Aperture)



Timed Exposure (Open Aperture)



Not stabilized over > 1 hour













Can we still measure the film?







Comparison:

With TiO₂ Film <u>versus</u> Without TiO₂ Film

Fluence used (TiO₂): 36 mJ/cm²










Do the darkened samples show thermal nonlinearities and how can we measure it?

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Thermally Managed Z-Scan

transmission

time



Falconieri & Salvetti App. Phys. B, 69, 133-136 (1999).

Thermally Managed Z-Scan





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Laser Parameters

w0 (measured):	37 micron
zR (from fitting):	2.1 mm
Approximate M ² :	1.8
Repetition Rate:	250 kHz
Pulse Duration:	100 fs
Power Used:	<u>300 mW</u>
Fluence:	0.06 J/cm ²
S parameter:	0.016

Amorphous film at start of window



Amorphous film at start of window



Amorphous film at end of window







Prefocal Time Dependence 1.10 1.05 1.00 0.95



Prefocal Time Dependence



Prefocal Time Dependence















As-deposited Amorphous Films

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Sensitive to light exposure

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Darkening occurs on two time scale: Short: 5.8 minutes Longer: 32 hours

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Does not recover after 12 hours

Darkened Films

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Thermal nonlinearity (dn/dT) is positive

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Thermal nonlinearity (dn/dT) is positive

Thermal response time is 0.6 ms

Discussion

TiO₂ is a promising nonlinear material

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Amorphous films: Adapted z-scan to measure n₂ Processing to enhance/avoid darkening

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Amorphous films: Adapted z-scan to measure n₂ Processing to enhance/avoid darkening

Darkened films require further study to: Understand process of darkening Explore properties of darkened samples

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